



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: U.S. Patent Application 09/760,066
Title: PROJECTION OBJECTIVE FOR MICROLITHOGRAPHY
Applicant: Schuster
Filed: January 12, 2001
Art Unit: 2873
Primary Examiner: Evelyn A. Lester
Examiner's Phone: (703) 308-4943
Examiner's Fax: (703) 308-7724
Attorney Docket (Z) 99023 P US

2001/13
6/15/03

Box Response
Commissioner for Patents
Washington, DC 20231

Amendment

Dear Examiner Lester:

This responds to the Office Action mailed December 4, 2002.

Please amend the application as follows:

05/30/2003 CNGUYEN 00000095 09760066

01 FC:1202	198.00 OP
02 FC:1201	588.00 OP
03 FC:1253	930.00 OP

RECEIVED
JUN -2 2003
TECHNOLOGY CENTER 2800

Regarding the specification, on page 2 of the Office Action the Examiner states that a substitute specification is required and maintains that the text of the current specification is difficult to read. We are not sure why the Examiner's copy is difficult to read because according to our records, the specification submitted was very clearly readable. Therefore we are submitting a COPY of the specification, with only the following change made to it. Therefore neither a substitute specification nor a marked-up copy should be necessary. It should be noted that in the previously submitted specification, the pages for the table were not numbered. This could inadvertently lead to the tables not staying in order during examination. The tables have been renumbered as pages 21-A through 21-N. No changes, beyond adding the page numbers, have been made to the specification.